

**Amendments to the Specification:**

Please replace the paragraph 0025 beginning at page 9, line 12 with the following rewritten paragraph:

[0025] As best seen in Figures 2 and 3, the first and second cathode members 112a and 112b, and specifically their respective channels, operatively interface selected parts of the wafer 108, namely, a first or peripheral part and a second or center part. Thereby, the etching solution 128 may be directed, via the first and second cathode members 112a and 112b, to the selected parts of the wafer 108, as further described below.